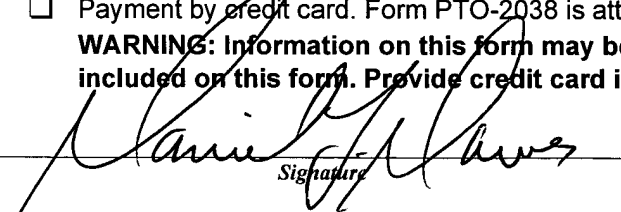
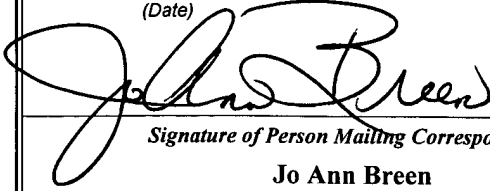
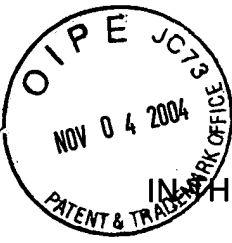


|   |                                     |                             |  |                                 |                          |
|---|-------------------------------------|-----------------------------|--|---------------------------------|--------------------------|
| <b>AMENDMENT TRANSMITTAL LETTER (Small Entity)</b><br>Applicant(s): Scherer et al.  |                                     |                             |  | Docket No.<br><b>CIT.PAU.01</b> |                          |
| Application No.<br>10/068,283   | Filing Date<br>Feb. 5, 2002         | Examiner<br>R. McDonald     | Customer No.<br>09533  | Group Art Unit<br>1753          | Confirmation No.<br>9733 |
| Invention: <b>DRY ETCHING AND MIRROR DEPOSITION PROCESSES FOR SILICONE ELASTOMER</b><br><br><b>(SECOND AMENDMENT AFTER FINAL)</b>   |                                     |                             |  |                                 |                          |
| <b>COMMISSIONER FOR PATENTS:</b>  |                                     |                             |  |                                 |                          |
| Transmitted herewith is an amendment in the above-identified application.   |                                     |                             |  |                                 |                          |
| <input checked="" type="checkbox"/> Applicant claims small entity status. See 37 CFR 1.27   |                                     |                             |  |                                 |                          |
| The fee has been calculated and is transmitted as shown below.  |                                     |                             |  |                                 |                          |
| <b>CLAIMS AS AMENDED</b>  |                                     |                             |  |                                 |                          |
|   | CLAIMS REMAINING<br>AFTER AMENDMENT | HIGHEST #<br>PREV. PAID FOR | NUMBER EXTRA<br>CLAIMS PRESENT   | RATE                            | ADDITIONAL<br>FEE        |
| TOTAL CLAIMS  | 15 -                                | 20 =                        | 0 x  | \$9.00                          | \$0.00                   |
| INDEP. CLAIMS   | 5 -                                 | 6 =                         | 0 x  | \$44.00                         | \$0.00                   |
| Multiple Dependent Claims (check if applicable) <input type="checkbox"/>  |                                     |                             |  |                                 | \$0.00                   |
| <b>TOTAL ADDITIONAL FEE FOR THIS AMENDMENT</b>  |                                     |                             |  |                                 | <b>\$0.00</b>            |
| <input checked="" type="checkbox"/> No additional fee is required for amendment.<br><input type="checkbox"/> Please charge Deposit Account No. _____ in the amount of _____<br><input type="checkbox"/> A check in the amount of _____ to cover the filing fee is enclosed.<br><input checked="" type="checkbox"/> The Director is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. <b>01-1960</b><br><input checked="" type="checkbox"/> Any additional filing fees required under 37 C.F.R. 1.16.<br><input checked="" type="checkbox"/> Any patent application processing fees under 37 CFR 1.17.<br><input type="checkbox"/> Payment by credit card. Form PTO-2038 is attached.<br><b>WARNING: Information on this form may become public. Credit card information should not be included on this form. Provide credit card information and authorization on PTO-2038.</b> |                                     |                             |  |                                 |                          |
| <br>Daniel L. Dawes, Reg. No. 27,123<br>MYERS DAWES ANDRAS & SHERMAN LLP<br>19900 MacArthur Boulevard<br>Irvine, California 92612  |                                     |                             | Dated: November 2, 2004<br><br><div style="border: 1px solid black; padding: 5px;">         I certify that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail in an envelope addressed to "Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450" [37 CFR 1.8(a)] on November 2, 2004.<br/> <div style="text-align: center;"> <br/>           Signature of Person Mailing Correspondence<br/> <b>Jo Ann Breen</b><br/>           Typed or Printed Name of Person Mailing Correspondence         </div> </div> |                                 |                          |



Patent  
CIT.PAU.01

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:  
Scherer et.al.

Examiner: R.McDonald  
Group Art Unit: 1753

Serial No.: 10/068,283

Filed: Feb. 5, 2002

For: Dry Etching and Mirror  
Deposition Processes for Silicone  
Elastomer

### SECOND AMENDMENT AFTER FINAL

Hon. Commissioner of Patents and Trademarks  
Washington DC 20231

Sir:

In reply to the Office Sept. 10, 2004, please consider the following  
remarks and enter the following amendments.

**Amendments to the Claims** are reflected in the listing of claims which  
begins on page 2 this paper.

**Remarks** begin on page 8 of this paper.